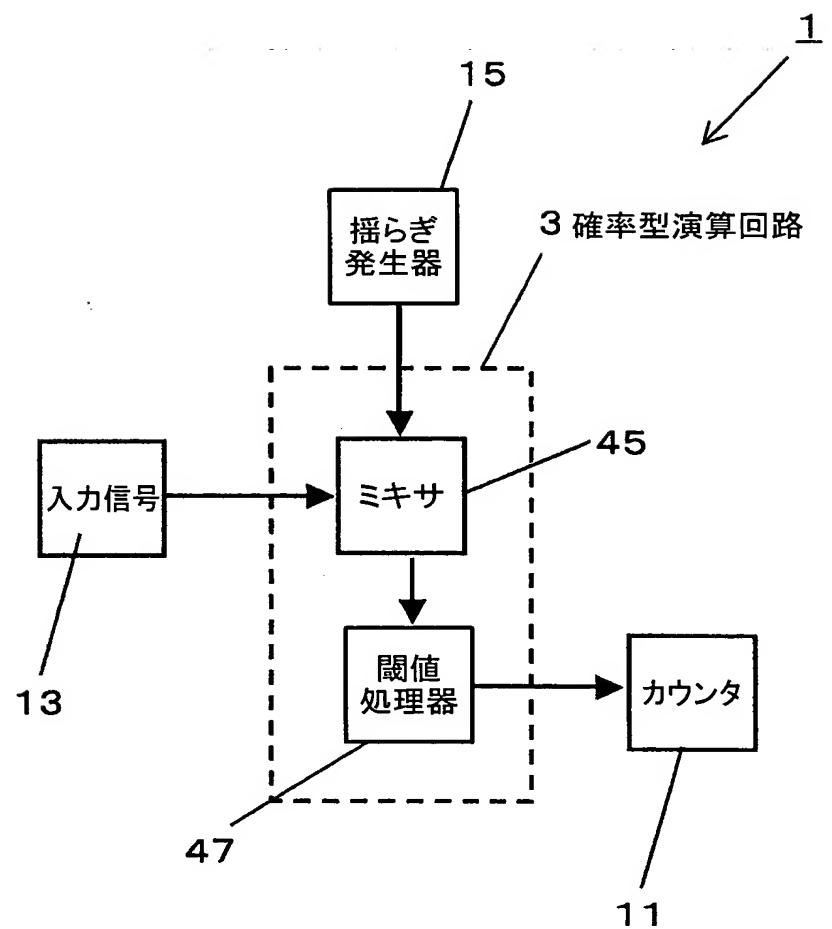
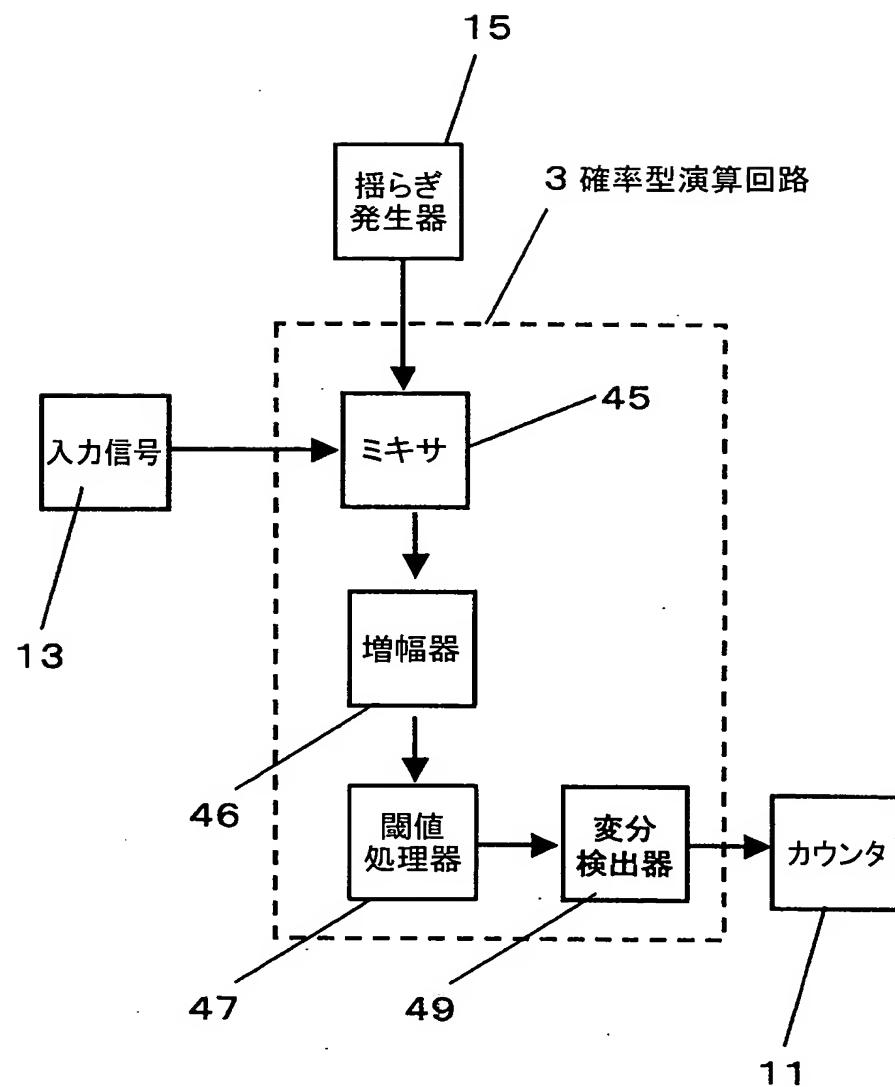


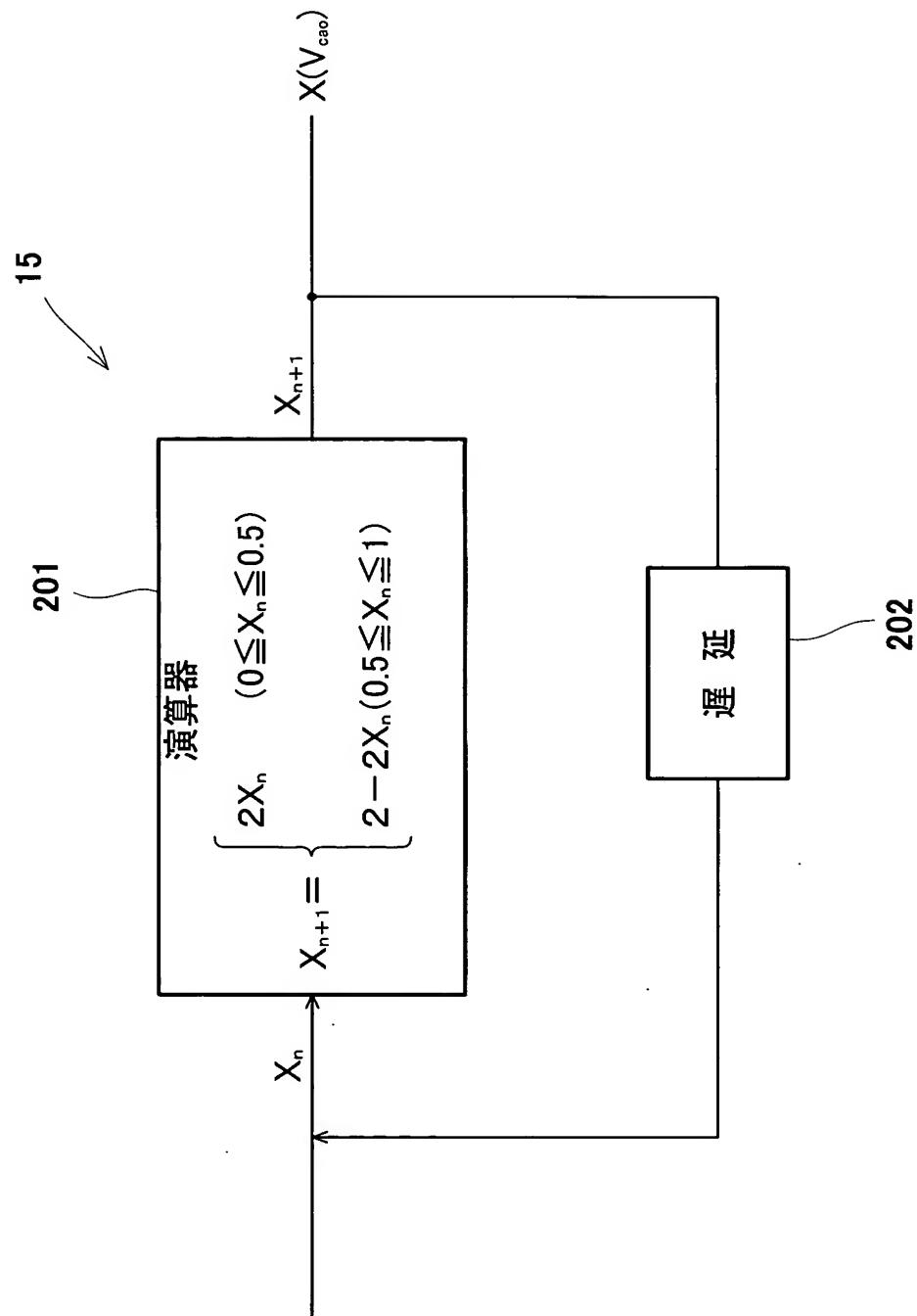
第1図



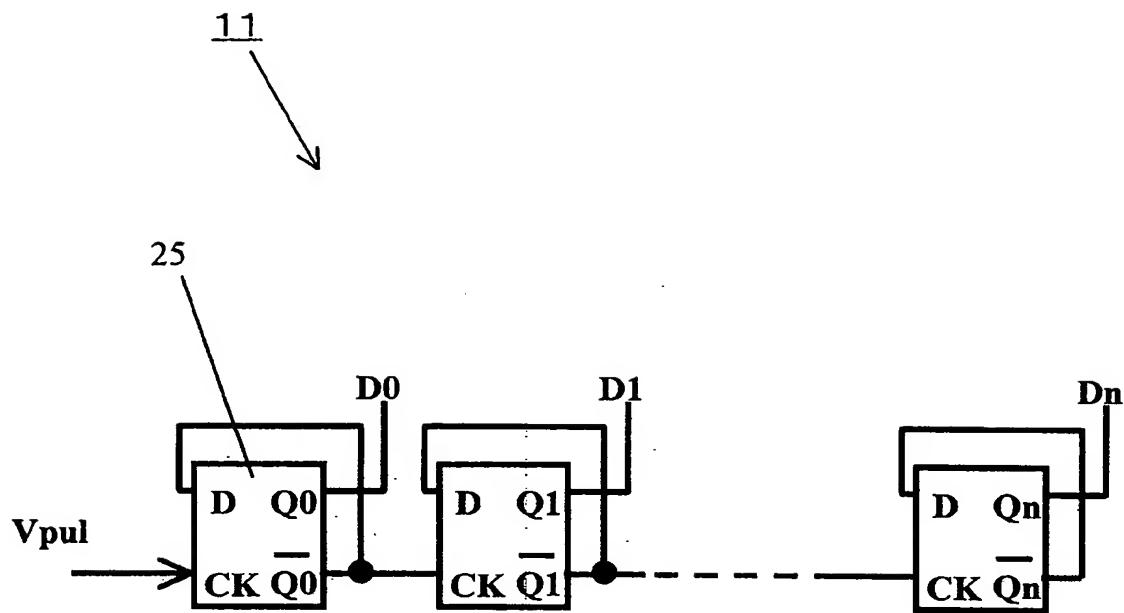
第 2 図



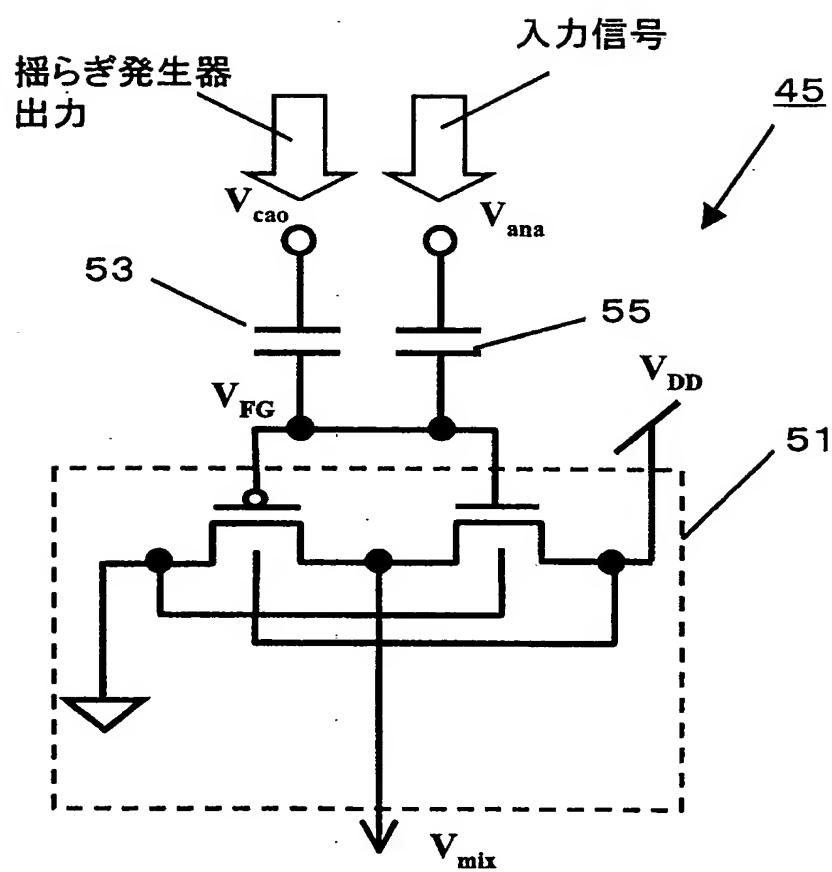
第3図



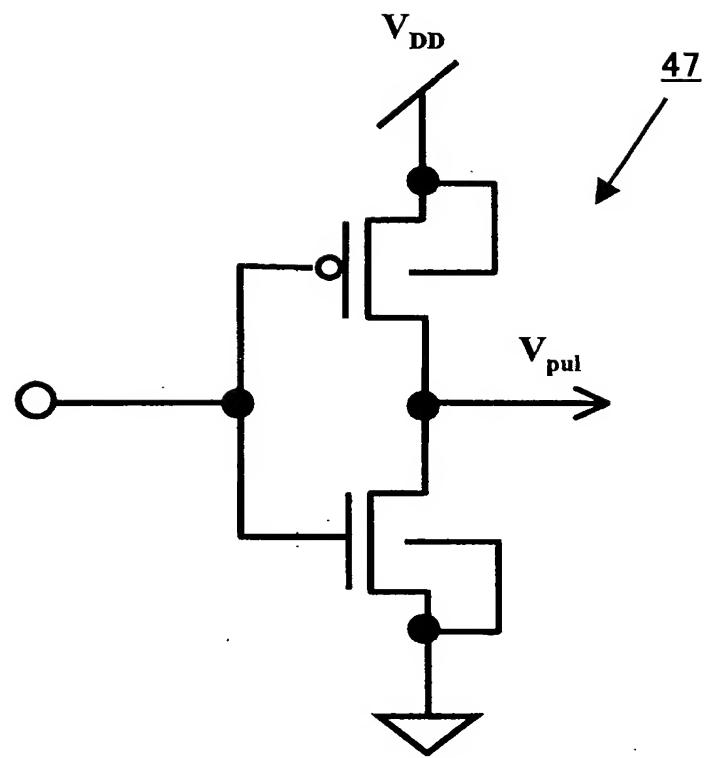
第4図



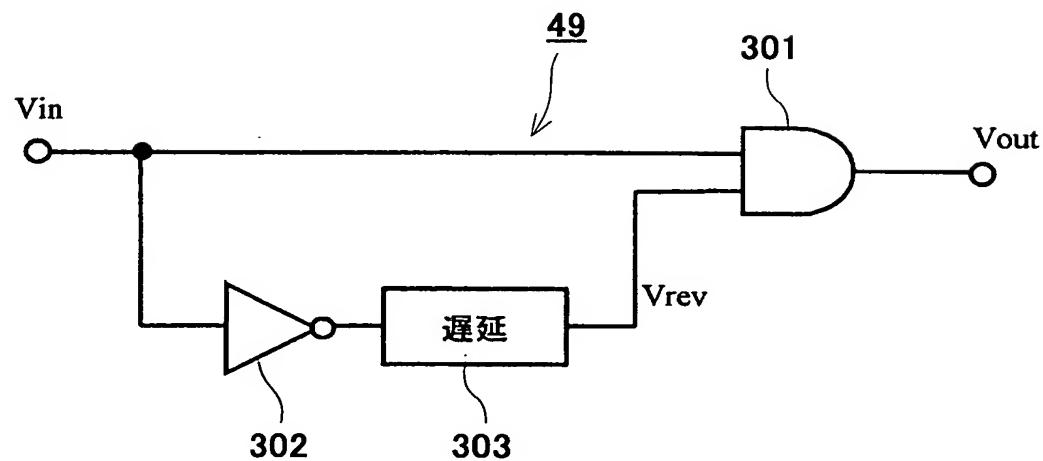
第5回



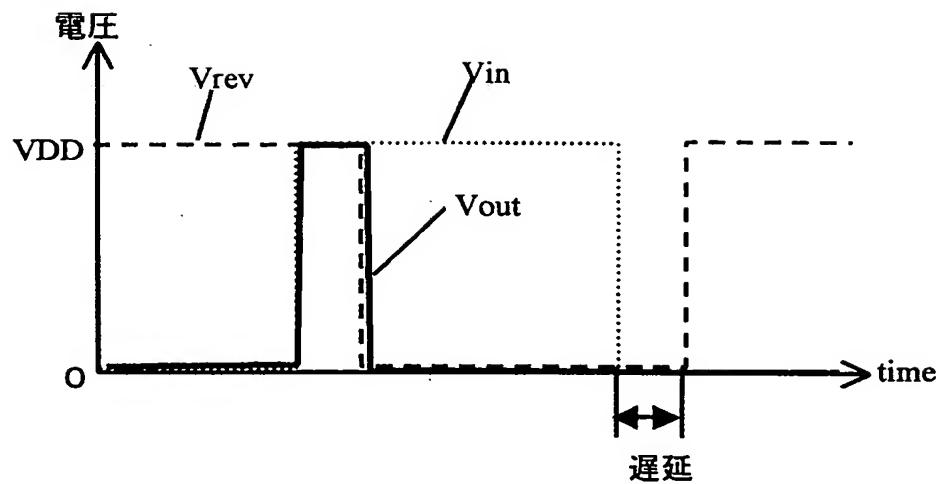
第 6 図



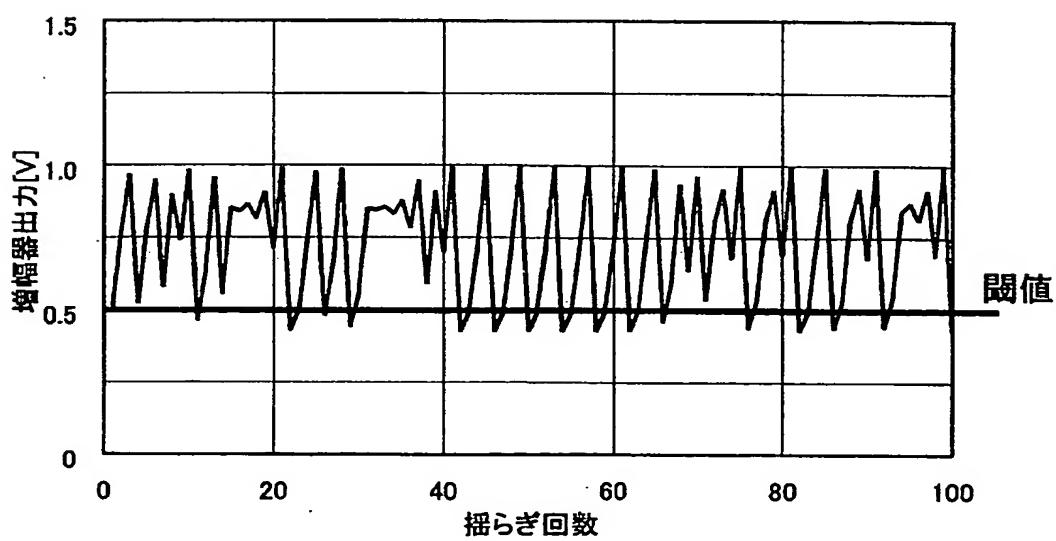
第 7 図



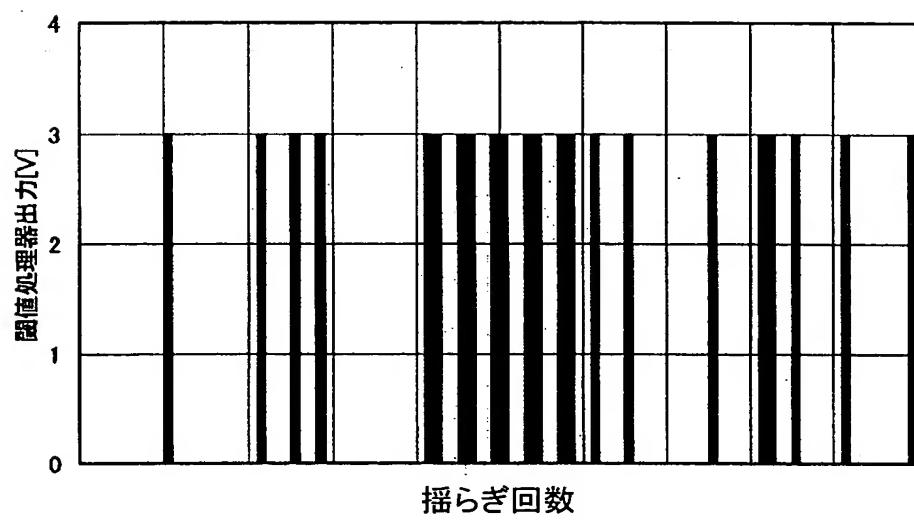
第 8 図



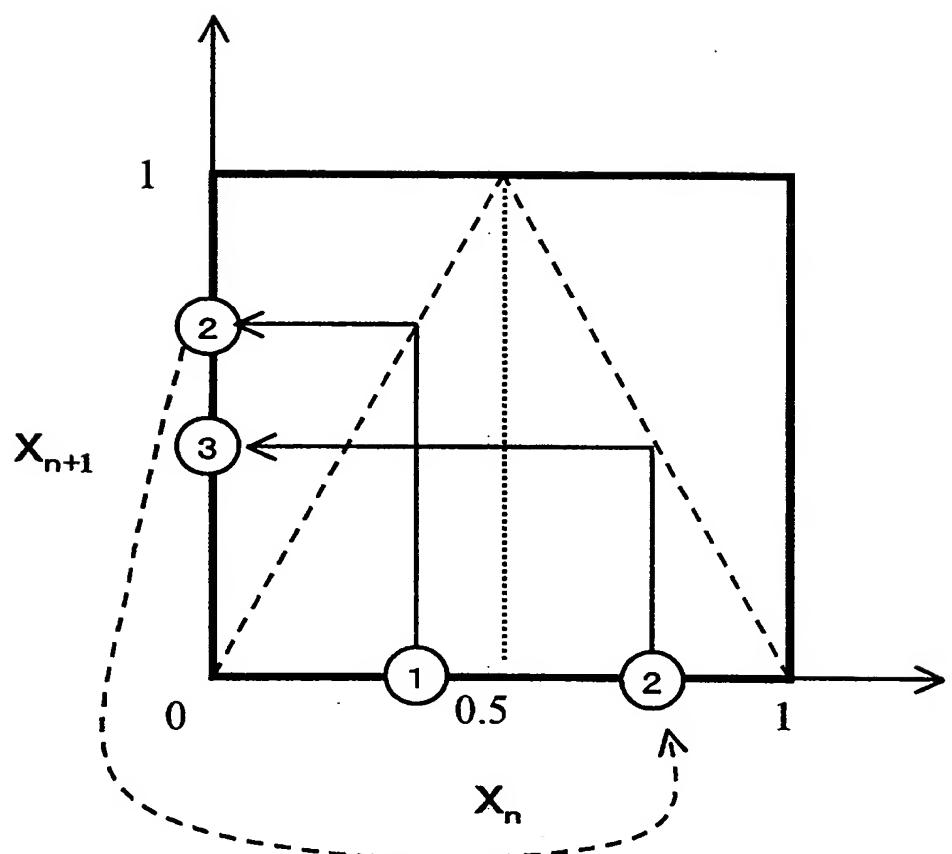
第 9 図



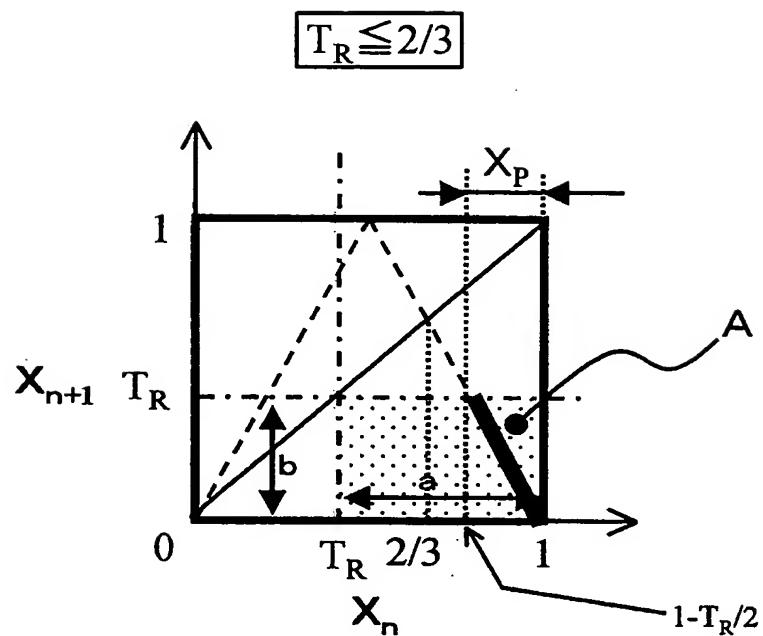
第 10 図



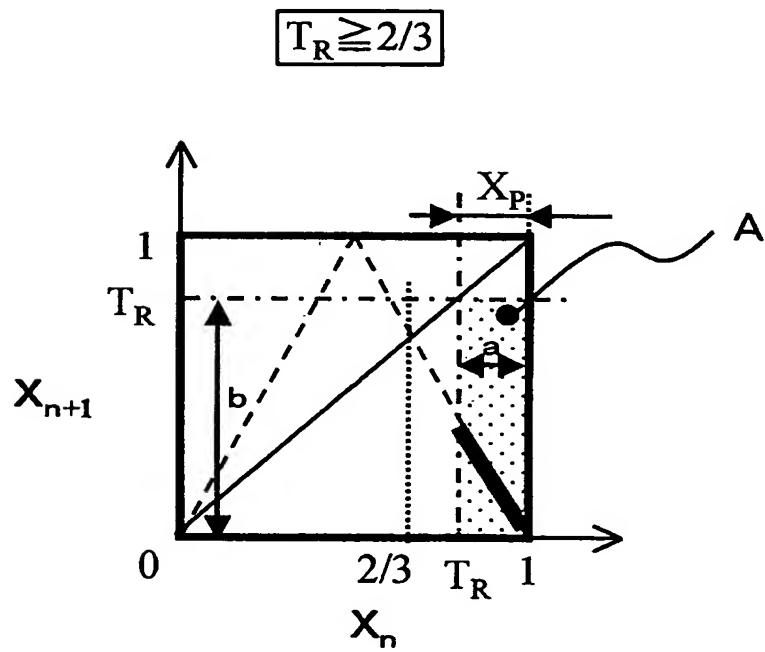
第 11 図



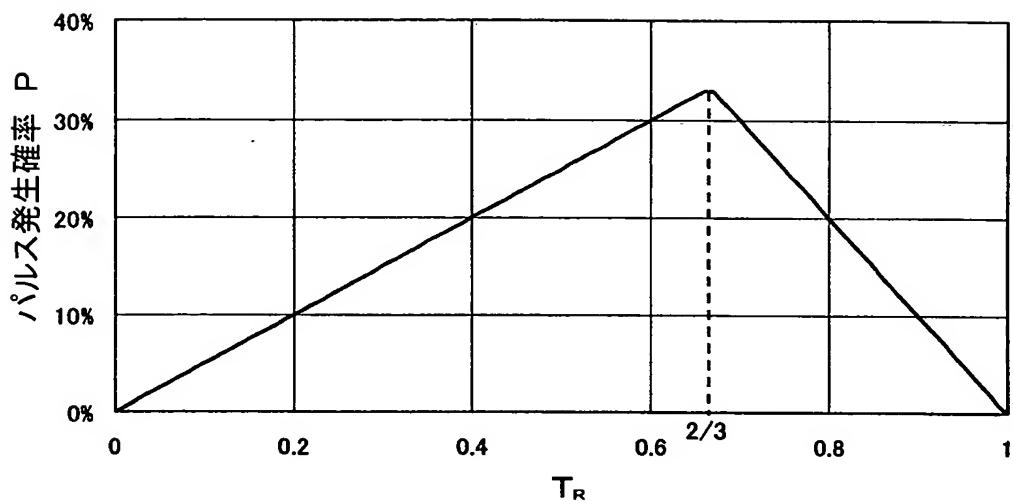
第12図A



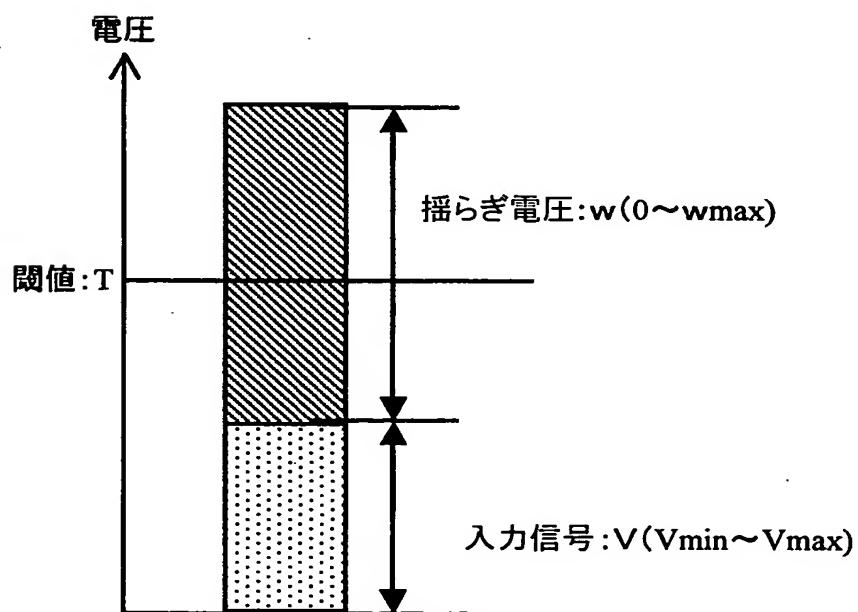
第12図B



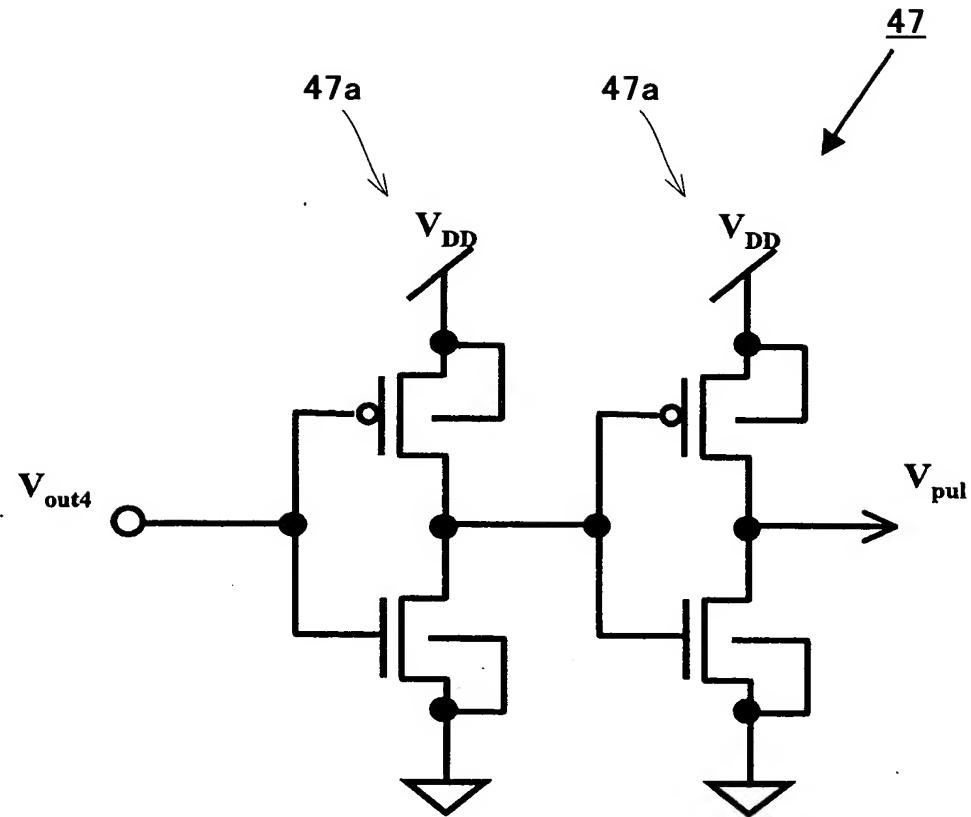
第 13 図



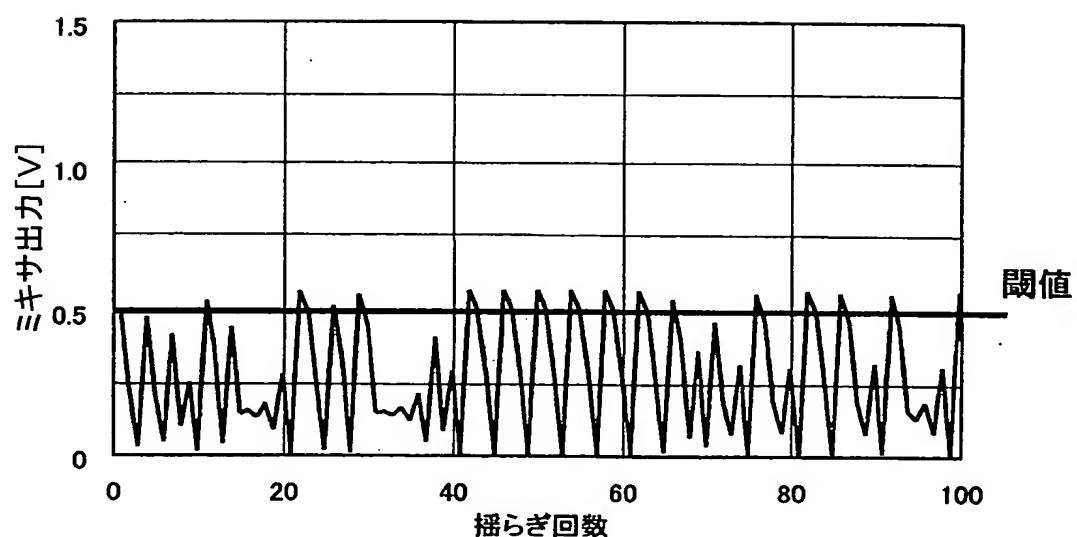
第 14 図



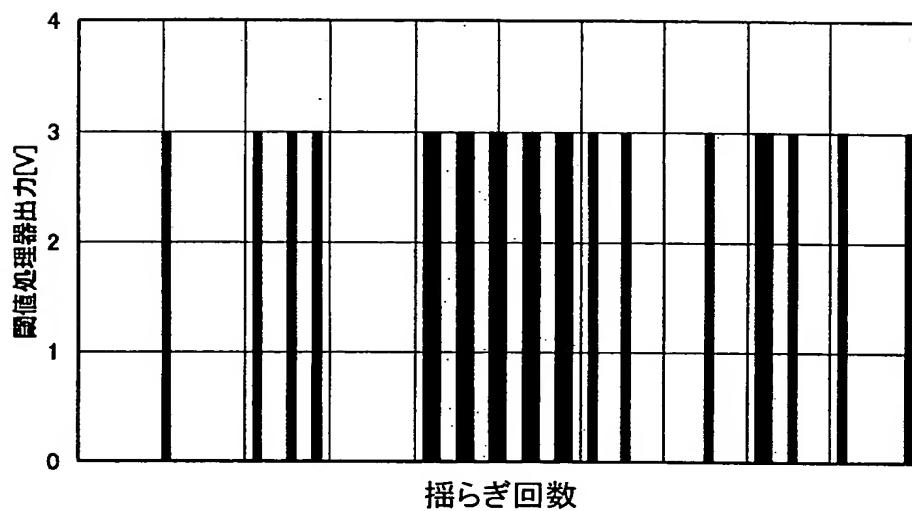
第 15 図



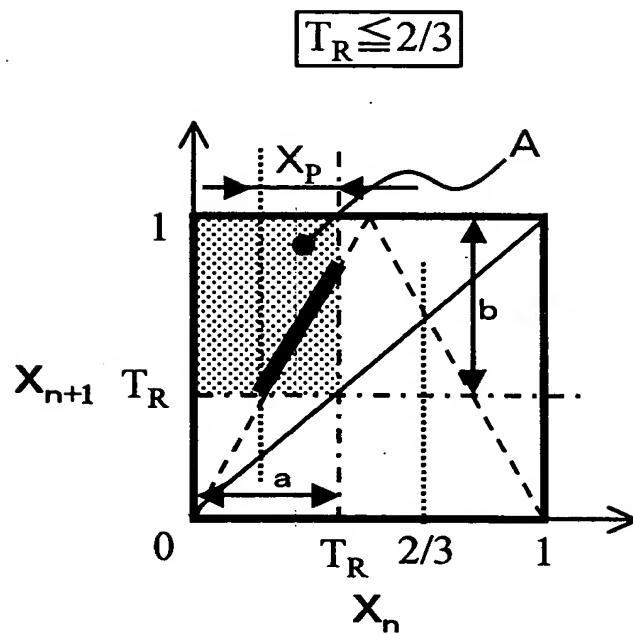
第 16 図



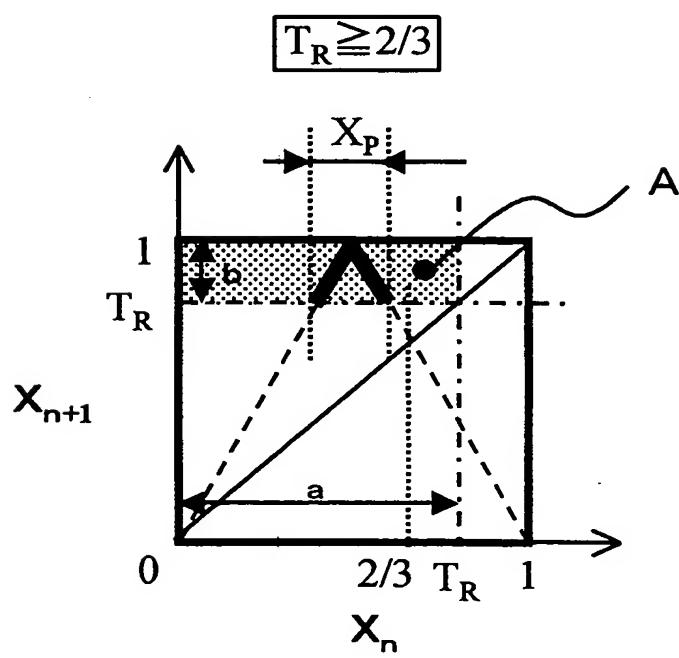
第 17 図



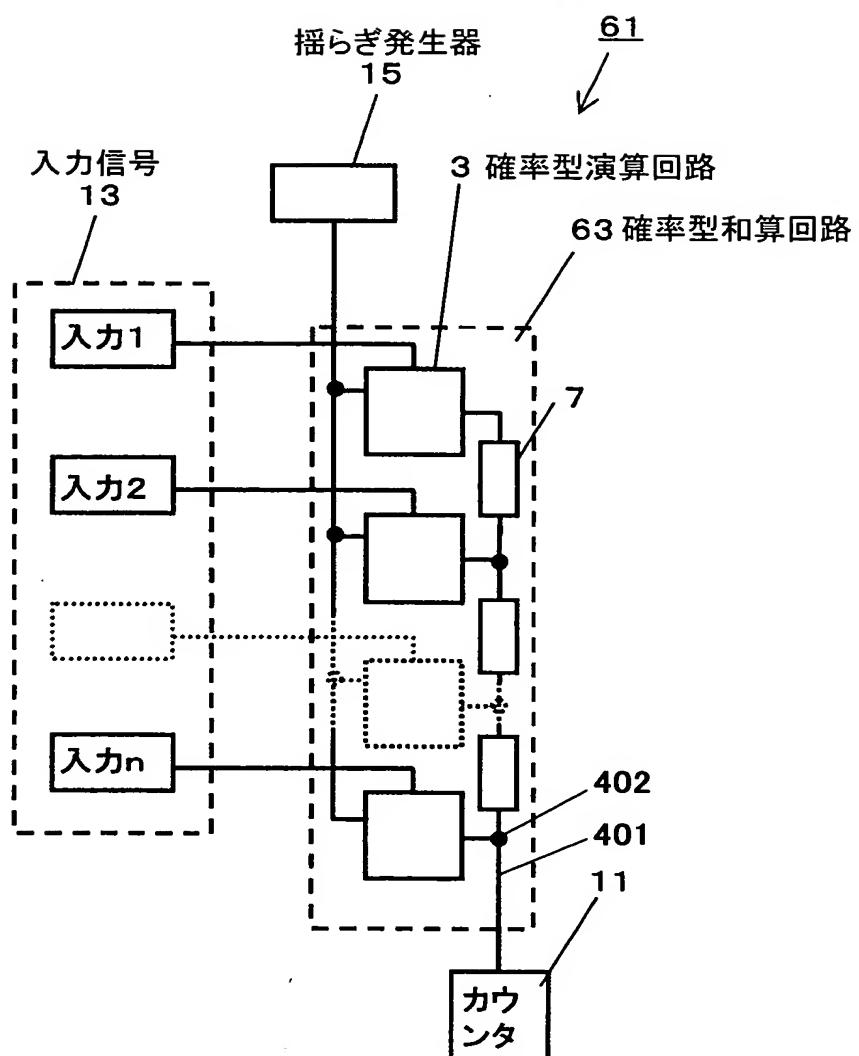
第18図A



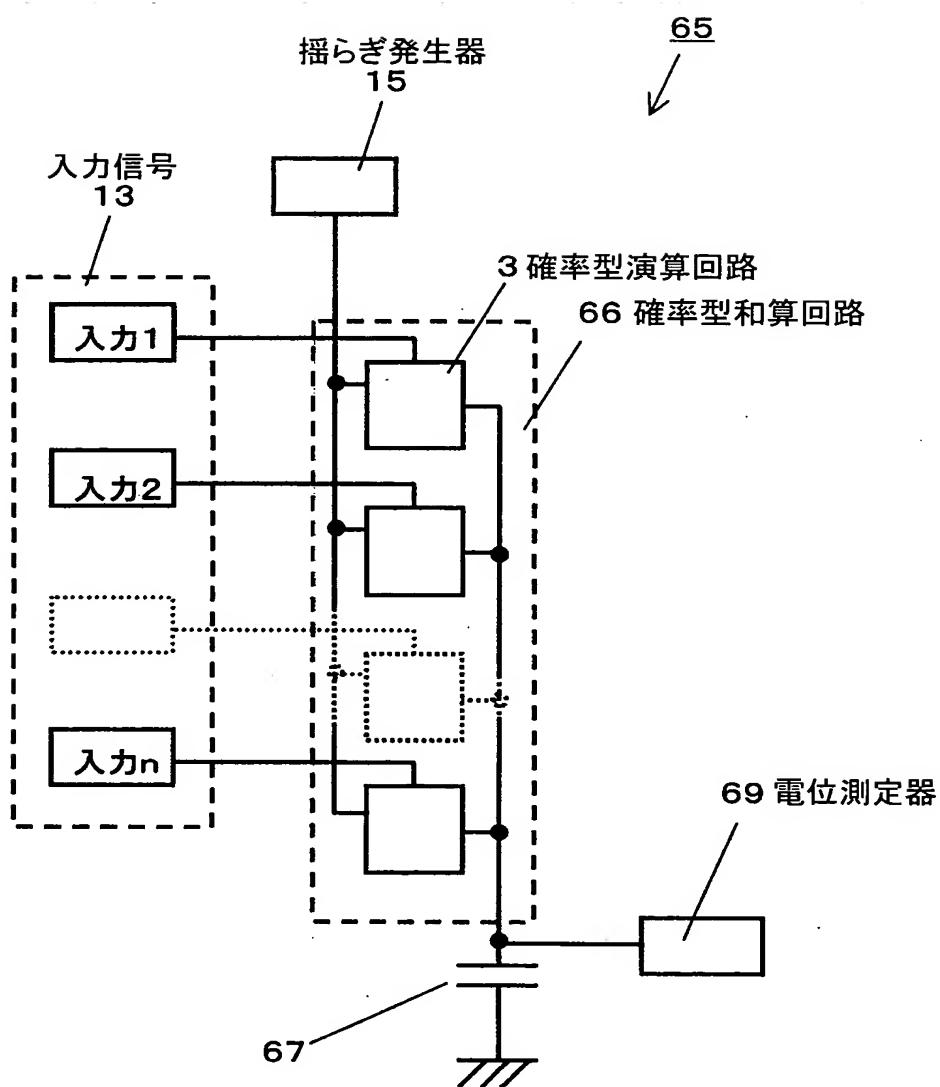
第18図B



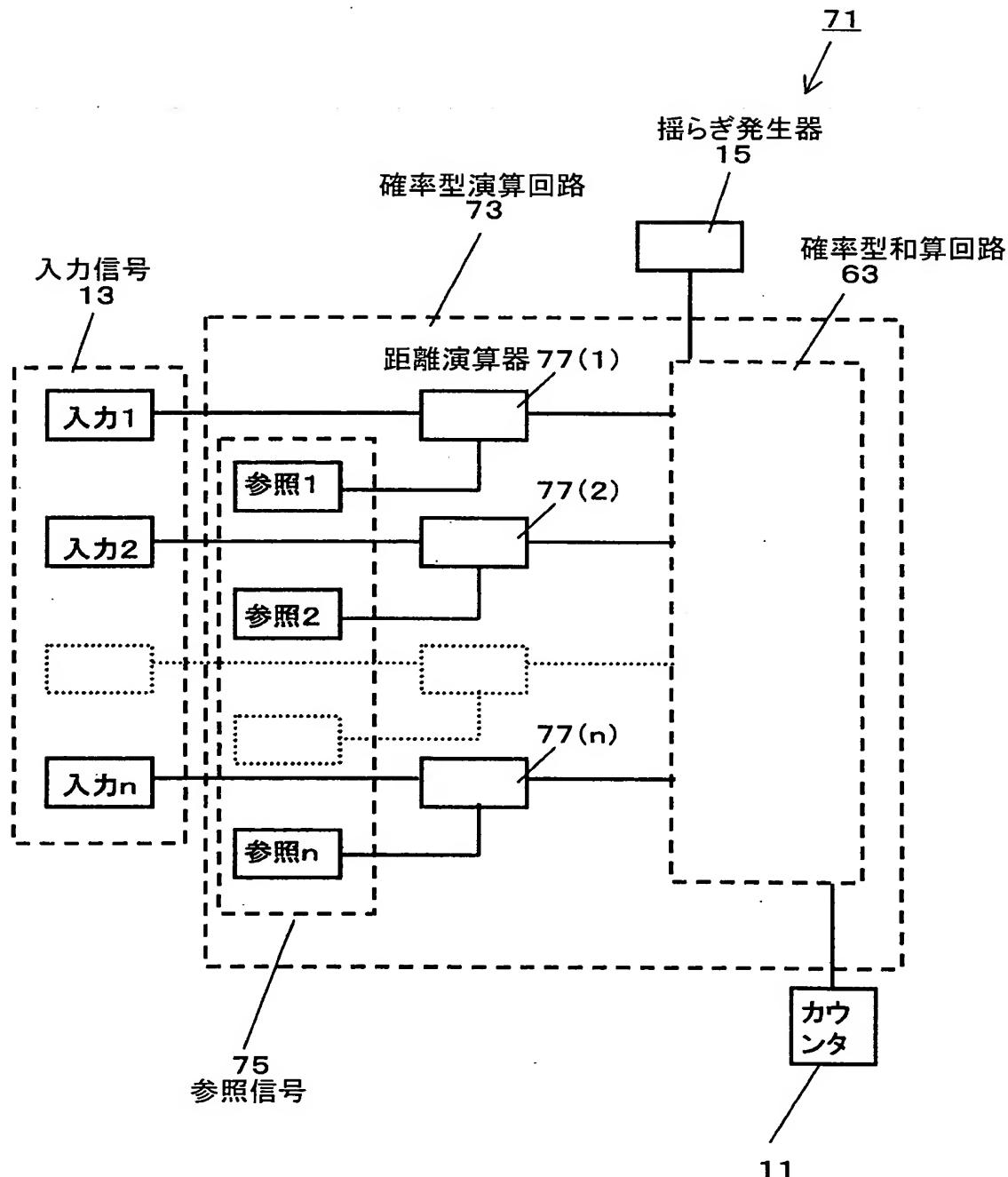
第19図



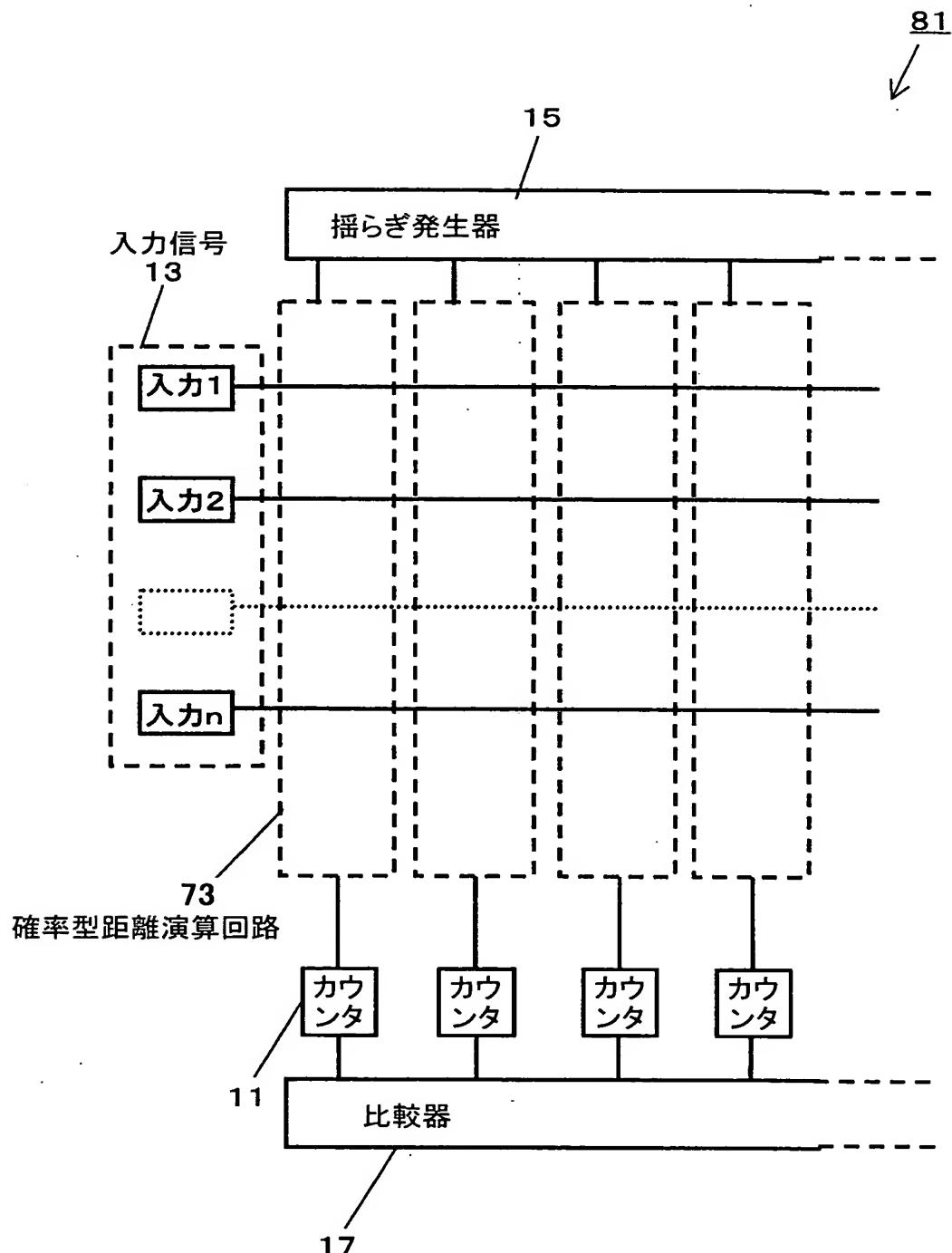
第 20 図



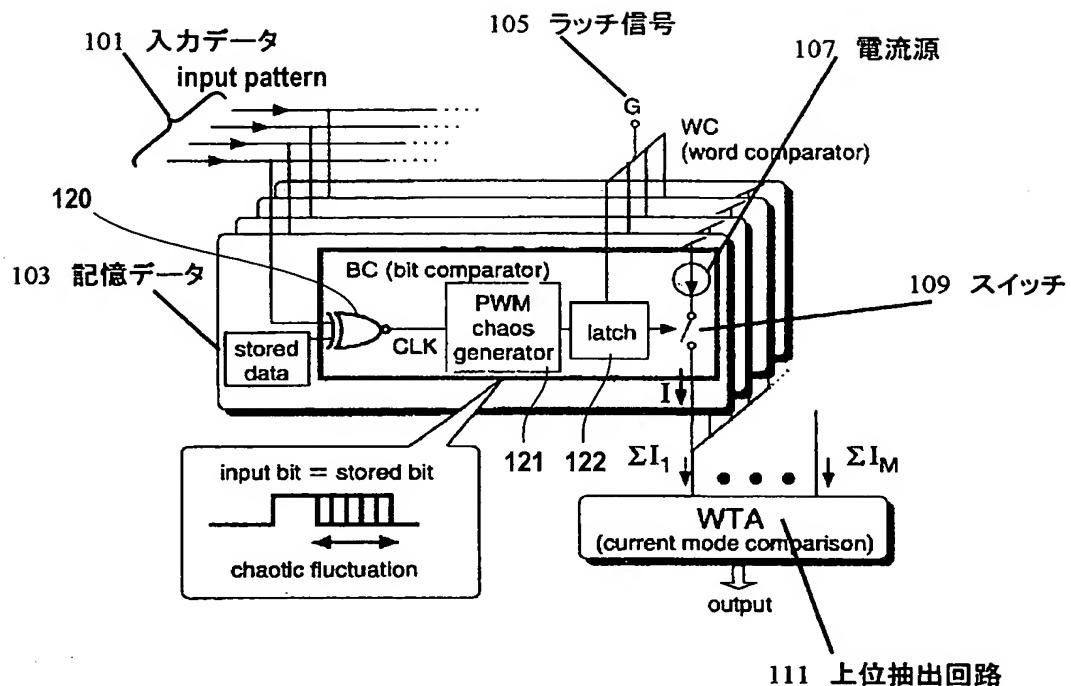
第 21 図



第 22 図



第23図(従来技術)



第24図(従来技術)

